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Substitute for form 1449A/PTO		<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number	10/058,557
(use as many sheets as necessary)		Filing Date	01/28/02
Sheet	1	of	2
		First Named Inventor	Chen et al.
		Group Art Unit	2812
		Examiner Name	Unknown
		Attorney Docket Number	AP01983

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	3/4/03
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation, if not in conformance and not considered. Include copy of this form with next communication to applicant.

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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ²
<i>JMM</i>		"Micromachines on the March" Janusz Bryzek, Kurt Petersen, and Wendell McCulley. IEEE Spectr, May 1994, pp 20-31.			
		"Ultra Thin ICs Open New Dimensions for Microelectric Systems" G. Klink, C. Landesberger, M. Feil, F. Ansorge, R. Aschenbrenner. Advancing Microelectronics, July/August 2000; pp.23-25.			
		"New Process Scheme for Wafer Thinning and Stress-free Separation of Ultra Thin ICs" C. Landesberger, S. Scherbaum, G. Schwinn, H. Spohrle. Proceedings of Microsystems Technologies 2001; pp.1-7.			
		"Innovative Packaging Concepts for Ultra Thin Integrated Circuits" G. Klink, M. Feil, F. Ansorge, R. Aschenbrenner, H. Reichl. Electronic Components and Technology Conference, 2001; pp. 1034-1039.			
		"Thin Silicon Chips and ACF Connection Technology for Contactless IC Cards" Mitsuo Usami. 1999 International Symposium on Microelectronics; pp. 309-312.			
		"Mechanical Lapping, Handling and Transfer of Ultra-Thin Wafers" S. Pinel, J. Tasselli, J.P. Bailbe, A. Marty, P. Puech and D. Esteve. Microengineering Vol. 8, 1998; pp 338-342.			
		"SmartCard Assembly Requires Advanced pre-Assembly Methods" Dr. J. Muller, P. Stampka, W. Krüninger, E. Gaulhofer, H. Oyrer. Semiconductor International, July 2000; pp. 191-200.			
		"Thin Monocrystalline Silicon Films on Flexible Substrates Enable Multiple Transfer Processes" C. Berger, Dr. R. Bergmann, D. J. Werner. MRS Bulletin, August 2001; pp. 603.			
		Khazan, A.D., "Transducers and Their Elements: Design and Application." Prentice-Hall, Inc. 1994, ISBN 03-13-929480-5. pp 393-395.			
<i>JMM</i>		"Packaging Very High Pressure Transducers for Common Rail Diesel Injection Systems" K. Sidhu, Measurement Specialties, Inc. October 1987, pp. 1-4			

Examiner Signature	<i>Patent Office</i>	Date Considered	3/15/03
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